IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Yoo, Woo Sik

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Assignee:

WaferMasters, Inc.

SEP 0 1 2004

Title:

Gas-Assisted Rapid Thermal Processing

Serial No.:

10/005,827

Filing Date:

November 8, 2001

Examiner:

Trinh, M.

Group Art Unit:

2822

Docket No.:

M-11914 US

Irvine, California September 1, 2004

MAIL STOP AF COMMISSIONER FOR PATENTS P.O. Box 1450 Arlington, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

In response to the Final Office Action dated May 5, 2004, Applicant submits the following amendments and remarks. A one-month extension of time, extending the period for response to September 5, 2004, is requested in an accompanying petition.

LAW OFFICES OF MACPHERSON KWOK CHEN & HEID U.F

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Serial No. 10/005,827

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